## Spring Plungers with Ball with Ventilation Hole

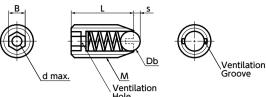






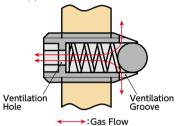








- For positioning in vacuum devices and vacuum chambers, such as FPD production equipment and semiconductor devices.
- Cleanroom wash and cleanroom packing are completed. → P.xxxx
- The thin fluorine coating keeps the ball highly lubricated, even after cleanroom washing.
- Ventilation holes and grooves easily release gas trapped in machines.



## Application

Fixing and locating workpiece, Vacuum devices, FPD production equipment, semiconductor devices

## Material/Finish



| • Material inisii | RoHS2 Compliant  |  |  |  |  |
|-------------------|--|--|--|--|--|
|                   | PVFS   |  |  |  |  |
| Main Body         | Equivalent to SUS304                                   |  |  |  |  |
| Ball              | SUS440C (Hardness 55 - 60HRC)<br>Thin Fluorine Coating |  |  |  |  |
| Spring            | SUS631J1   |  |  |  |  |

Unit:mm

|               |     |     |    |     |     |     |                       |          | 01110-111111 |
|---------------|-----|-----|----|-----|-----|-----|-----------------------|----------|--------------|
| Part Number 1 | M   | s   | L  | Db  | В   | d   | Load (N)<br>min./max. | Mass (g) | Qty per pack |
| PVFS-5        | M5  | 0.9 | 12 | 3   | 2.5 | 1.5 | 5.7 / 9.6             | 0.9      | 1            |
| PVFS-6        | M6  | 1   | 14 | 3.5 | 3   | 2   | 6.9 / 13              | 1.5      | 1            |
| PVFS-8        | M8  | 1.5 | 16 | 5   | 4   | 2   | 9.5 / 16              | 3.5      | 1            |
| PVFS-10       | M10 | 2   | 19 | 6   | 5   | 3   | 16 / 28               | 7        | 1            |

## • Part number specification





